



## INFORMATION DISCLOSURE

### CITATION

~~ATTY. DOCKET NO.~~

**900-411**

APPLICANT

YAMAMOTO et al.

FILING DATE

January 10, 2002

**SERIAL NO.**

10/041,681

**GROUP**

1753

RECEIVED  
JUL 18 2003  
GROUP 1700

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**OTHER DOCUMENTS** (including Author, Title, Date, Pertinent pages, etc.)

ADD	"Effects of Substrates with Different Surface Morphology on Microcrystalline Silicon Solar Cells", Nasuno et al., page 829, 6a-C-6, 9-2000.
ADD	"Effects of Substrates with Different Surface Morphology on Microcrystalline Silicon Solar Cells", Nasuno et al., April 2001, pages L-303-L305
ADD	"Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature Using PECVD", Nasuno et al., Korea, 2001, pages 791-794
ADD	"Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature Using RF-PECVD", Nasuno et al., Sept. 2000
ADD	"Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature", Nasuno et al., 2001, pages A15.5.1-12

\*Examiner

Date Considered

8/14/03

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

Form PTO-FB-A820 (Also PTO-1449)